



GE Dkt. No. RD-28420-1 Atty. Dkt. No. 040849-0177

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Yu WANG et al.

Title:

HIGH FIELD OPEN MRI MAGNET

ISOLATION SYSTEM AND METHOD

Appl. No.:

09/682,519

Filing Date:

9/13/2001

Examiner:

Bernard Rojas

Art Unit:

2832

Confirmation

2614

Number:

## **AMENDMENT AND REPLY UNDER 37 CFR 1.111**

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This communication is responsive to the Non-Final Office Action dated December 1, 2006, concerning the above-referenced patent application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this document.

Remarks/Arguments begin on page 5 of this document.

Please amend the application as follows: